



46379

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Takashi FUJII et al. :
Serial No.: 10/784,211 :
Filed: February 24, 2004 :
For: PROCESS FOR PRODUCING COLD :
FIELD-EMISSION CATHODES :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, Applicants bring the disclosures attached and listed on completed Form PTO-1449 to the Examiner's attention and request that they be considered and made of record in this application.

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

Garrett V. Davis
Reg. No. 32,023

Roylance, Abrams, Berdo & Goodman, L.L.P.
1300 19th Street, N.W., Suite 600
Washington, D.C. 20036-1649
(202) 659-9076

Dated: May 20, 2004

